Docket No.: 059516-0052

## <u>PATENT</u>

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Customer Number: 20277

Zi-Kui LIU, et al.

Confirmation Number: 1022

Application No.: 10/784,899

Group Art Unit: 1775

Filed: February 24, 2004

Examiner: Not yet assigned

For: BORIDE THIN FILMS ON SILICON

## <u>INFORMATION DISCLOSURE STATEMENT</u>

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed more than three months after the U.S. filing date AND after the mailing date of the first Office Action on the merits, but before the mailing date of a Final Rejection or Notice of Allowance.

10/784,899

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## **CERTIFICATION PARAGRAPH**

The undersigned certifies that each item of information contained in this Information

Disclosure Statement was first cited in a communication from a foreign patent office in a

counterpart foreign application not more than three months prior to the filing of this Information

Disclosure Statement as described in 37 CFR 1.97(e)(1).

Each non-English language reference was cited in a corresponding foreign application search report or office action and its relevance discussed therein. A copy of the foreign search report or office action, together with an English language version thereof, is attached for the Examiner's information.

Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

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Date: March 25, 2005

Please recognize our Customer No. 20277 as our correspondence address.

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OIPE CITY					APPLICANT Zi-Kui LIU, et al.					
MAR 2 5 2005 (PTO-1449)  U.S. PATENT						February 24, 2004 1775				
TRADEM			U	I.S. PATEN	T DOCUMENTS					
EXAMINER'S INITIALS	CITE NO.	Document Number Number-Kind Code2 (# known)		Publication Dat MM-DD-YYYY			Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear			
		US 6,797,341 B2		09/28/2004	Zeng et al.	Zeng et al.				
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		ZENG, Xianghui., et al. "In situ epitaxial MgB₂ thin films for superconducting electronics." Nature Materials, Volume 1, September 2002, www.nature.com/naturematerials pp. 1-4								
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EXAMINER					DATE CONSIDERED					

<sup>\*</sup>EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.